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\*Admitted only in Maryland  
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Federal Agencies

June 7, 2004

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Commissioner for Patents  
PO Box 1450  
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**Art Unit 2823**

Re: U.S. Utility Patent Application  
Application No. 09/753,664; Filed: January 4, 2001  
For: **High Density Metal Capacitor Using Via Etched Stopping Layer as  
Field Dielectric in Dual-Damascene Interconnect Process**  
Inventor: Liming Tsau  
Our Ref: 1875.0230000

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Letter to PTO Draftsman: Submission of Formal Drawings;
2. 13 sheets of drawings: (Figures 1-15, 16A-16I, 17A-17I, 18A-18I and 19A-19I); and
3. One (1) return postcard.

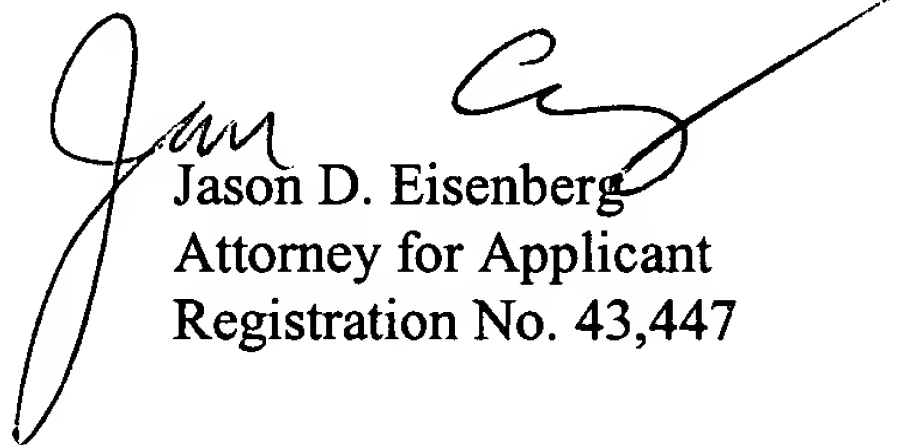
It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

Commissioner for Patents  
June 7, 2004  
Page 2

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.



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273040\_1.DOC



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Liming Tsau

Appl. No.: 09/753,664

Filed: January 4, 2001

For: **High Density Metal Capacitor  
Using Via Etched Stopping Layer  
as Field Dielectric in Dual-  
Damascene Interconnect Process**

Confirmation No.: 1902

Art Unit: 2823

Examiner: K. Nguyen

Atty. Docket: 1875.0230000

**Letter to PTO Draftsman: Submission of Formal Drawings**

Commissioner for Patents  
PO Box 1450  
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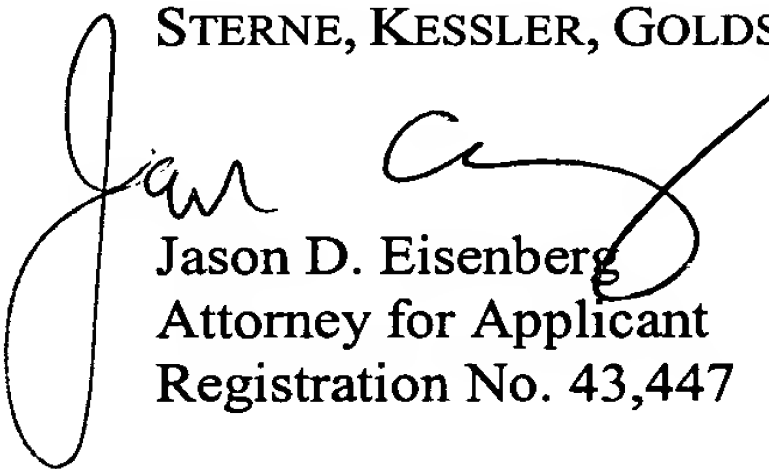
Sir:

Submitted herewith are thirteen sheets of formal drawings with Figures 1-15, 16A-16I, 17A-17I, 18A-18I and 19A-19I, corresponding to the informal drawings submitted with the above-captioned application. Identification of the drawings is provided in accordance with 37 C.F.R. § 1.84(c). Acknowledgment of the receipt, approval, and entry of these formal drawings into this application is respectfully requested.

It is not believed that an extension of time is required, other than any already provided herewith. However, if an extension of time is needed to prevent abandonment of the application, then such extension of time is hereby petitioned. The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

  
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Date: June 7, 2004

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